


IDS - 10/13/2005 ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention	METHOD AND SYSTEM FOR DYNAMIC MODELING AND RECIPE OPTIMIZATION OF SEMICONDUCTOR ETCH PROCESSES						
 Application Number : 10/523777 							
Confirmation Number: 5732							
First Named Applicant: Kun Li							
Attorney Docket Number: VOY007US							
Art Unit: 2825							
Examiner:							
Search string: (6133132).pn							
 US Patent Documents							
Note: Applicant is not required to submit a paper copy of cited US Patent Documents							
init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
SRG	1	6133132	2000-10-17	Toprac et al.			
 Signature							
Examiner Name				Date			
/Steven Garland/				08/09/2006			